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**BOX AF**

AMENDMENT UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE  
GROUP 2621  
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE  
**RECEIVED**

In re application of

Docket No: Q56532

JUL 18 2003

Hideya TAKEO

Technology Center 2600

Appln. No.: 09/489,846

Group Art Unit: 2621

Confirmation No.: 6337

Examiner: Ryan J. Miller

Filed: January 24, 2000

For: ABNORMAL PATTERN DETECTION PROCESSING METHOD AND SYSTEM

**AMENDMENT UNDER 37 C.F.R. § 1.116**

**MAIL STOP AF**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated April 16, 2003, please amend the above-identified application as follows:

7-10 2621 E AF/2621  
DRAFTED  
7-19-03  
2700